	Application No.	Applicant(s)
Notice of Allowability	09/328,939	FUJIMURA ET AL.
	Examiner	Art Unit
	Shamim Ahmed	1765
The MAILING DATE of this communication apperation allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RI of the Office or upon petition by the applicant. See 37 CFR 1.313	(OR REMAINS) CLOSED in thi or other appropriate communic GHTS. This application is subj	is application. If not included cation will be mailed in due course. THIS
1. This communication is responsive to <u>3/31/05</u> .		
2. The allowed claim(s) is/are 1.2.5,9-11.21 and 23-29.		
3. The drawings filed on <u>09 June 1999</u> are accepted by the Ex	kaminer.	
 4. Acknowledgment is made of a claim for foreign priority una) All b) Some* c) None of the: Certified copies of the priority documents have Certified copies of the priority documents have Copies of the certified copies of the priority documents have Copies of the certified copies of the priority documents have International Bureau (PCT Rule 17.2(a)). * Certified copies not received: Applicant has THREE MONTHS FROM THE "MAILING DATE" on the complexity of the priority documents have THIS THREE-MONTH PERIOD IS NOT EXTENDABLE. 	been received. been received in Application Notuments have been received in the property of this communication to file a received.	lo this national stage application from the
5. A SUBSTITUTE OATH OR DECLARATION must be submit INFORMAL PATENT APPLICATION (PTO-152) which give	tted. Note the attached EXAMI s reason(s) why the oath or de	NER'S AMENDMENT or NOTICE OF claration is deficient.
6. CORRECTED DRAWINGS (as "replacement sheets") mus (a) including changes required by the Notice of Draftspers 1) hereto or 2) to Paper No./Mail Date (b) including changes required by the attached Examiner's Paper No./Mail Date Identifying indicia such as the application number (see 37 CFR 1. each sheet. Replacement sheet(s) should be labeled as such in the depose to the de	on's Patent Drawing Review (I Amendment / Comment or in 84(c)) should be written on the d ne header according to 37 CFR 1	the Office action of rawings in the front (not the back) of .121(d).
 DEPOSIT OF and/or INFORMATION about the depose attached Examiner's comment regarding REQUIREMENT INFORMATION. 	FOR THE DEPOSIT OF BIOLO	AL must be submitted. Note the OGICAL MATERIAL.
Attachment(s) 1. Notice of References Cited (PTO-892) 2. Notice of Draftperson's Patent Drawing Review (PTO-948) 3. Information Disclosure Statements (PTO-1449 or PTO/SB/06 Paper No./Mail Date 则此处。 4. Examiner's Comment Regarding Requirement for Deposit of Biological Material	6. ⊠ Interview Sumr Paper No./Ma 8), 7. ⊠ Examiner's Am	il Date

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U.S. Patent and Trademark Office PTOL-37 (Rev. 1-04)

EXAMINER'S AMENDMENT

1. An examiner's amendment to the record appears below. Should the changes and/or additions be unacceptable to applicant, an amendment may be filed as provided by 37 CFR 1.312. To ensure consideration of such an amendment, it MUST be submitted no later than the payment of the issue fee.

Authorization for this examiner's amendment was given in a telephone interview with Kent Tobin on 6/20/05.

The application has been amended as follows:

IN THE CLAIMS:

In claim 1, line 9, after "1/480," replace the phrase "the method further comprising" with "wherein" and

In claim 1, line 10, after the phrase "to be processed", replace the word "with" with "is exposed to".

In claim 23, at the last line, after "1/480", insert " , wherein the object to be processed is exposed to atomic hydrogen from the plasma discharge".

Cancel claim 30.

2. The following is an examiner's statement of reasons for allowance: Applicant's arguments filed on 3/31/05 are persuasive as to the point that the closest prior art Moslehi (5,089,441) fails to teach the claimed flow ratio as defined in claims 1 and 23 in order to expose the substrate to be processed to atomic hydrogen from the plasma discharge.

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3. The closest prior art, Moslehi teaches HCl or HBr is introduced in the basic mixture of GeH4 + H₂ through nonplasma gas manifold with out any direct plasma discharge activation for enhancing metallic contaminants removal (col.9, lines 19-39).

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Therefore, Moslehi does not suggest that the flow ratio can be optimized as a result effective variable in order to increase the flow rate of the HCI/HBr (Gas B) halides relative to hydrogen (Gas A).

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Shamim Ahmed whose telephone number is (571) 272-1457. The examiner can normally be reached on M-Thu (7:00-5:30) Every Friday Off.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Nadine G. Norton can be reached on (571) 272-1465. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Shamim Ahmed Primary Examiner Art Unit 1765

SA June 20, 2005